

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE ECEIVED

P.J. LaCour et al.

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Application No.: 09/781,128

Group Art Unit: 2815

Filed:

February 9, 2001

Examiner: C.C. Chu

Title:

DATA MANAGEMENT METHOD FOR RETICLE/MASK WRITING

## AMENDMENT AND REQUEST FOR RECONSIDERATION

Seattle, Washington 98101

February 24, 2004

## TO THE COMMISSIONER FOR PATENTS:

## **INTRODUCTORY COMMENTS**

In response to the Office Action mailed on August 25, 2003, please make the following amendments to the application.